

<b>Notice of References Cited</b>	Application/Control No. 10/518,194		Applicant(s)/Patent Under Reexamination NOMURA ET AL.	
	Examiner EDNA WONG		Art Unit 1795	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 07022473 A	01-1995	Japan	TAKENAKA et al.	H01L 21/60
*	O	JP 63250492 A	10-1988	Japan	SHIOBARA, TAKASHI	C25D 7/06
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Masui et al., "Warp Control in Strip Processing Plant", ISIJ International, Vol. 31 (no month, 1991), No. 3, pp. 262-267.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.